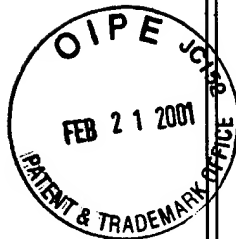


GAU-28783/12/01
#4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): HAIMING WANG ET AL.
Assignee: KLA-TENCOR CORPORATION
Title: SYSTEM FOR ANALYZING SURFACE CHARACTERISTICS WITH
SELF-CALIBRATING CAPABILITY
Serial No.: 09/405,716 Filed: September 24, 1999
Examiner: Unknown Group Art Unit: 2878
Docket No.: M-10684-2P US



San Jose, California
February 15, 2001

NOTICE OF CHANGE OF ADDRESS

COMMISSIONER FOR PATENTS
Washington, D. C. 20231

Sir:

Please direct all correspondence in the above-identified application and with respect to
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Tammy L. Kaplan Date of Signature

Respectfully submitted,

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